Butterfly Haptics



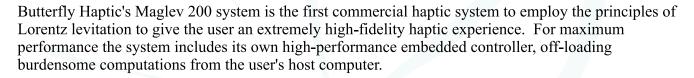
SYSTEM

Maglev 200[™] Magnetic Levitation Haptic Interface

A breakthrough in haptics

Maglev Haptics[™] is a revolutionary new technology for high-fidelity interaction with virtual or remote environments through the sense of touch. The user grasps a handle rigidly attached to a flotor levitated by strong magnetic fields. The handle can be freely moved in six degrees of freedom through a comfortable motion range, sending position and orientation information to the user's application. The application, in turn, outputs forces and torques to the handle.

Available haptic-interaction devices are small back-driven robot arms, which include mechanical elements that can limit fidelity due to friction, backlash, link bending, and motor cogging. These drawbacks are eliminated with Maglev HapticsTM.



The hardware incorporates several highly innovative design features and advanced manufacturing technologies to provide high quality and reliable operation at a reasonable cost.



Six degrees of freedom
Single moving part
Zero static friction
Zero mechanical backlash
High bandwidths
High position resolution
Wide stiffness range
Mechanical simplicity

Advanced applications

Medical/dental training
Microsurgery
Data set visualization
Character animation
Effort-reflected flight
Computer aided design
Remote robot control
Micro/nano manipulation

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Top View



Bottom View
Model 201 Device



Front View



Back View
Model 202 Controller

The Butterfly Haptics Maglev 200 system includes the Model 201 device, Model 202 controller, cables, detachable mouse-like handle, desktop mounting kit, manuals, and client-side software (API, graphical monitor, and demos).

Design features

Degrees of Freedom 6,	upgradable to 7
Amplifiers Low	Noise Linear
Handle Int	cerchangeable
Included Handle Mou	ıse-Like
Handle Buttons 2	
Device Pose Ad	justable 0-90 deg.
Device Mass (Model 201) 18	Kg
Device Diameter 0.4	10 m sphere
Controller Mass (Model 202) 14.	5 Kg
Controller Dimensions 0.2	$20 \times 0.45 \times 0.53 \text{ m}$
Power Requirements 115	5V/6A, 230V/3A

Performance characteristics

Translational Workspace	24 mm Dia.Sphere
Rotational Range	+/-8 deg (see note 1)
Position Resolution (1 sigma)	< 2.0 microns
Angular Resolution (1 sigma)	3.6 arcsec
Position Bandwidth (-3dB)	140 Hz
Force Bandwidth at Manipulandum.	>2000 Hz
Peak Force (Z axis)	40 N
Force Resolution	20 mN
Peak Torque (Z axis)	3.6 Nm
Maximum Translational Stiffness	50 N/mm
Minimum Translational Stiffness	
Maximum Rotational Stiffness	5.1 Nm/deg
Minimum Rotational Stiffness	0.01 Nm/deg
Backdrive Static Friction	0.0 N
Mechanical Backlash	0.0 microns
Perceived Mass (Flotor)	616 g
Maximum Servo Rate	4000 Hz
Levitation Power	4.5 W
Stray Field at Handle	0.001T

Software

Embedded RT Operating System QNX 6.3
Communication
User Interface (C/C++ Language). Structured API
Testing and Debugging FacilityGraphical Monitor
Host OS Compatibility Linux, Windows
Haptic API Compatibility CHAI 3D, MATLAB®
Note 1: Rotational range is reduced near the limits of the